# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Moshe Finarov

Assignee:

Nova Measuring Instruments, Inc.

Title:

APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING

**POLISHING** 

Serial No.:

09/047,944

Filed:

March 25, 1998

Examiner:

E. Morgan

Group Art Unit:

3723

Docket No.:

M-3417-1C US

San Jose, California August 25, 1995

# **ASSOCIATE POWER OF ATTORNEY (37 C.F.R. § 1.34)**

Dear Sir:

The undersigned Attorney of Record hereby appoints the attorney named below as an Associate Attorney in the above-identified application with full powers to prosecute said application; to make alterations and amendments therein; to receive all notices, communications and said Letters Patent at the address indicated below; and to transact all business in the U.S. Patent and Trademark Office in connection therewith

The undersigned Attorney of Record hereby appoints:

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SER. NO. 09/047,944



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Respectfully submitted,

David W. Heid

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